

10/018699

531 Rec'd PCT

12 DEC 2001

PATENT

#61a

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s)	Janssens, et al.	Examiner:	Unassigned
Serial No.:	Unassigned	Group Art Unit:	Unassigned
Confirmation No.:	Unassigned	Docket:	294-114 PCT/US
Filed:	Herewith	Dated:	December 12, 2001
For:	METHOD AND APPARATUS FOR DETERMINING A FLOW PATTERN OF A FLUID IN A SPACE		

Commissioner for Patents
Washington, DC 20231

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on December 12, 2001*

Signature: _____

**PRELIMINARY AMENDMENT**

Sir:

In order to place the application in proper form for examination, Applicants hereby
amend the specification as follows:

IN THE SPECIFICATION:

On page 1, before line 1, after the title, please insert the following:

21
This application is the U.S. National Phase of International Application Number
PCT/IB00/00865 filed on June 28, 2000, which is incorporated herein by reference.

BACKGROUND OF THE INVENTION

The invention relates to a method for determining a low pattern of a fluid in a space.